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KANEKO.014AUS

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Minoru Umemoto et al.) Group Art Unit
Serial No. : New Application)
Filed : Concurrently Herewith)
For : PROCESS OF FORMING)
ULTRAFINE CRYSTAL LAYER, MACHINE)
COMPONENT HAVING ULTRAFINE CRYSTAL LAYER)
FORMED BY THE ULTRAFINE CRYSTAL LAYER)
FORMING PROCESS, PROCESS OF PRODUCING)
THE MACHINE COMPONENT, PROCESS OF FORMING)
NANOCRYSTAL LAYER, MACHINE COMPONENT)
HAVING NANOCRYSTAL LAYER FORMED BY THE)
NANOCRYSTAL LAYER FORMING PROCESS, AND)
PROCESS OF PRODUCING THE MACHINE COMPONENT)
Examiner : Unknown)

PRELIMINARY AMENDMENT

Hon. Commissioner
of Patents and Trademarks
Alexandria, VA 22313-1450

Dear Sir:

This preliminary amendment is submitted for the above-identified patent application which is entrance of national stage of U.S.A based on International Application No. PCT/JP2004/018650. Please make the following changes: